

Notice of References Cited	Application/Control No. 10/764,605		Applicant(s)/Patent Under Reexamination HARTZELL ET AL.	
	Examiner David S. Kim		Art Unit 2613	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B	US-2002/0140081 A1	10-2002	Chou et al.	257/700
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*	D	US-7,049,676 B2	05-2006	Tanabe et al.	257/508
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	M	US-			

FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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